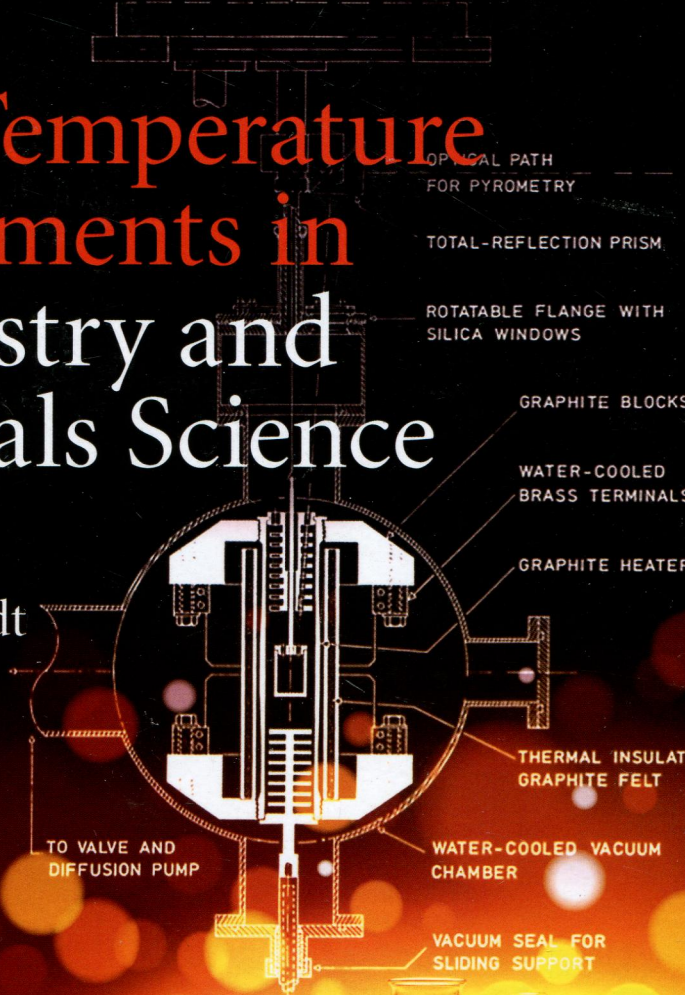


# High Temperature Experiments in Chemistry and Materials Science

Ketil Motzfeldt



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